

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Document Number (Optional)

TSMC-01-413

Application Number

10/060,483

Applicant

Yen-Ming Chen et al.

Filing Date

01/30/02

Group Art Unit

2812

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
11	5543253	8/6/96	Park et al.	439	5	12/16/94
	6042996	3/28/00	Lin et al.	430	313	4/13/98
	6232212	5/15/01	Degani et al.	438	612	2/23/99
	6153503	11/28/00	Lin et al.	438	613	3/10/98
	6130141	10/10/00	Degani et al.	438	455	10/14/98
	6118180	9/12/00	Loo et al.	257	737	11/3/97

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portrains Pages, Etc.)

EXAMINER

Vicki Tish

DATE CONSIDERED

3/29/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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